



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
FUKUMI

Appl. No. 09/993,897

Filed: November 27, 2001

For: SEMICONDUCTOR SUBSTRATE AND METHOD FOR FABRICATING THE
SAME

Atty. Ref.: 829-590; Confirmation No.
Group: 2812

Examiner: Roman, Angel

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 23, 2004

Sir:

AMENDMENT AFTER FINAL

Responsive to the Official Action dated November 25, 2003, please amend the
above-identified application as follows:

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JAN 28 2004
TECHNOLOGY CENTER 2800

Do not enter
Amendment
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